



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

13/Response
7-10-03

In re Application of:

Han, K. Michael

Serial No.: 09/904,042

Filed: July 11, 2001

For: **Recessed Tunnel Oxide Profile For
Improved Reliability In NAND
Devices**

Art Unit: 2815

Examiner: Wojciechowicz, Edward

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RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Final Office Action* dated April 9, 2003 in the above-referenced patent application. Please enter and consider the following remarks.